

Application Data Sheet

Application Information

Application Type::	Regular
Subject Matter::	Utility
Suggested classification::	
Suggested Group Art Unit::	
CD-ROM or CD-R?::	None
Computer Readable Form (CRF)?::	No
Title::	APPARATUS AND METHOD OF CLEANING A SUBSTRATE
Attorney Docket Number::	025311-0114
Request for Early Publication?::	No
Request for Non-Publication?::	No
Suggested Drawing Figure::	1
Total Drawing Sheets::	3
Small Entity?::	No
Petition included?::	No
Secrecy Order in Parent Appl.?::	No

Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japanese
Status::	Full Capacity
Given Name::	Satoshi
Family Name::	KUME
City of Residence::	Kanagawa

Country of Residence:: Japan
Street of mailing address:: c/o Semiconductor Leading Edge Technologies, Inc.
292 Yoshida-cho, Totsuka-ku
Yokohama, 244-0817, Kanagawa
Country of mailing address:: Japan

Correspondence Information

Correspondence Customer Number:: 22428
E-Mail address:: wellis@foleylaw.com

Representative Information

Representative Customer Number::	22428	
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Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2001-016964	01/25/2001	Yes

Assignee Information

Assignee name::

SEMICONDUCTOR LEADING EDGE
TECHNOLOGIES, INC.

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